

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/700,505	NATSUKA ET AL.	L.	
Examiner	Art Unit		
Taayaan Kim	1651		

	SEARCHED			
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
updated search (EAST, PubMed, GenBank search)	2/12/2009	тк	